



INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	10/737,363
				Filing Date	December 16, 2003
				First Named Inventor	Clark T.-C. Nguyen, et al.
				Group Art Unit	2817
				Examiner Name	Barbara Summons
Sheet	1	of	1	Attorney Docket Number	UOM 0285 PUSP

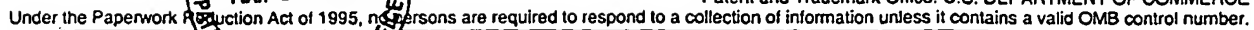
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BS		WANG, KUN, ET AL., VHF Free-Free Beam High-Q Micromechanical Resonators, Journal of Microelectromechanical Systems, Vol. 9, No. 3, September 2000, pp. 453-458	
BS		ONOE, M., Contour Vibrations of Isotropic Circular Plates, The Journal of the Acoustical Society of America, Vol. 28, No. 6, November 1954, pp. 1158-1162	
BS		POURKAMALI, S., ET AL., A 600 KHz Electrically-Coupled MEMS Bandpass Filter, Dig. Of Papers Int. Conf. of Microelectromechanical Systems, MEMS 2003, Japan, January 2003, pp. 702-705	

Examiner Signature	Barbara Summons	Date Considered	4/4/05
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BS	-	NGUYEN, CLARK, T.-C., Microelectromechanical Components For Miniaturized Low-Power Communications, Proceedings, 1999 IEEE MTT-S International Microwave Symposium RF MEMS Workshop, Anaheim, California, June 18, 1999, pp. 48-77			
BS	-	NGUYEN, CLARK, T.-C., Micromechanical Circuits For Communication Transceivers, Proceedings, 2000 Bipolar/BiCMOS Circuits and Technology Meeting (BCTM), Minneapolis, Minnesota, September 25-26, 2000, pp. 142-149			
BS	-	TANG, WILLIAM C., ET AL., Laterally Driven Polysilicon Resonant Microstructures, Sensors and Actuators, Vol. 20, 1989, Abstract only			
BS	-	NGUYEN, CLARK, T.-C., An Integrated CMOS Micromechanical Resonator High-Q Oscillator, IEEE Journal of Solid-State Circuits, Vol. 34, No. 4, April 1999, pp. 440-455			
BS	-	WANG, KUN, ET AL., High-Order Medium Frequency Micromechanical Electronic Filters, IEEE, Journal of Microelectromechanical Systems, Vol. 8, No. 4, December 1999, pp. 534-557			
BS	-	BANNON, FRANK D., ET AL., High-Q HF Microelectromechanical Filters, IEEE Journal of Solid-State Circuits, Vol. 35, No. 4, April 2000, pp. 512-526			
BS	-	LEE, SEUNGBAE, ET AL., A 10-MHz Micromechanical Resonator Pierce Reference Oscillator for Communications, Digest of Technical Papers, Transducers 2001, Munich, Germany, June 10-14, 2001, pp. 1094-1097			
BS	-	CLARK, JOHN R., ET AL., High-Q VHF Micromechanical Contour-Mode Disk Resonators, Technical Digest, IEEE Int. Electron Devices Meeting, (IEDM), San Francisco, California, December 11-13, 2000, pp. 493-496			
BS	-	WONG, ARK CHEW, ET AL., A Bonded Microplatform Technology for Modular Merging of RF MEMS and Transfer Circuits, Digest of Papers Int. Conf. on Solid-State Sensors and Actuators, Transducers 2001, June 10-14, 2001			
BS	-	ABDELMONEUM, MOHAMED A., ET AL., Stemless Wine-Glass-Mode Disk Micromechanical Resonators, Digest of Papers Int. Conference of Microelectromechanical Systems (MEMS 2003), January 2003, Kyoto, Japan, pp. 698-701,			

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BS		HSU, WAN-THAI, ET AL., A Sub-Micron Capacitive-Gap Process For Multiple-Metal-Electrode Lateral Micromechanical Resonators, Technical Diges, IEEE Int. Micromechanical Systems Conf., Interlaken, Switzerland, January 21-25, 2001, pp. 349-352	
BS		WAKE, R. N., ET AL., Changes In The Natural Frequencies of Repeated Mode Pairs Induced By Cracks In A Vibrating Ring, IEEE Journal of Sound and Vibration, Vol. 214, No. 4, November 1998, pp. 761-770	
BS		DEMIRCI, MUSTAFA U., ET AL., Mechanically Corner-Coupled-Square Microresonator Array For Reduced Series Motional Resistance, Digest of Papers Int. Conf. on Solid-State Sensors and Actuators, Transducers 2003, June 8-12, 2003	
BS		CLARK, JOHN R., ET AL., High-Q UHF Micromechanical Radial-Contour Mode Disk Resonators, submitted for publication in IEEE Journal of Microelectromechanical Systems on April 29, 2003, pp. 1-10	
BS		FUJITA, T., ET AL., Disk Shaped Bulk Micromachined Gyroscope With Vacuum Sealing, Sensors and Actuators, Vol. 82, May 2000, pp. 198-204	

(Pages are missing being re-cited on the 892)

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